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	To the Director, U.S. I	Patent a	11110 ALBERT ALBERT (1818 1818) 1818 1818	Mar and contract	hed original docum		- 41 C
1. Name of conveying party(ies): A) NORITAKA UKIYO, B) TETSURO SAITO, C) TATSUMI SHOJI, D) MAKOTO IWAKAMI, E) TAKEHITO YOSHINO, F) SHOJI NISHIDA, G) MASAAKI IWANE AND H) MASAKI MIZUTANI				Name: CANON KABUSHIKI KAISHA			
		•	OIFE				
	Additional name(s) of conve	X No	/ DEC 2 N 20mm	Foreign Addı	ress: 30-2, Shimomar		ıe, Ohta-ku
3.	Nature of conveyance:		Ta, S	4	Tokyo, Japan		
	X Assignment Security Agreement Other		of Name	Domestic Ad	dress:		
	Execution Date: a) Novembe						
2001, c) November 26, 2001 d) November 26, 2001, e) November 21, 2001, f) November 22, 2001, g) November 22, 2001 and h) November 22, 2001.			City:	S	State	ZIP	
14040	<u> </u>			Additional na	ame(s) & address(es)	attached?	Yes X No
4. Application number(s) or patent number(s): If this document is being filed together with a new application, the execution date of the application is:							
	A. Patent Application Number: 09/964,332 Filing Date: September 28, 2001			B. Title of Invention: METHOD AND APPARATUS FOR PRODUCING SEMICONDUCTOR THIN FILMS			
		Additional n	umbers attached?	∏ Yes	X No		
	Name and address of party to whom correspondence concerning document should be mailed:		ondence	6. Number of applications and patents involved:			
]	Name: Fitzpatric	k, Cella, Harpe	r & Scinto		One	<u></u>	
	30 Rocke	feller Plaza		7. Total fee	(37 CFR 3.41):	. \$	40.00
-		k, New York 10)112-3801	X Enclos	sed rized to be charged to	o deposit ac	count
,	Felephone No.:(212) 218	3-2100		8. Deposit a	ccount number (for d	leficiency or	excess)
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9. \$	Statement and signature.			<u> </u>			
	To the best of my knowledge copy of the original documen		foregoing informatio	on is true and th	e attached is the orig	ginal docum	ent or is a true
<u></u>		ini) dans	December 1	9. 2001
Name of Person Signing Signature Date							
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PATENT REEL: 012384 FRAME: 0888

JOINT

(AFTER APPLICATION FILED)

ASSIGNMENT OF PATENT RIGHTS FOR THE UNITED STATES

FOR VALUE RECEIVED, WE, Noritaka Ukiyo, Tetsuro Saito, Tatsumi Shoji, Makoto Iwakami, Takehito Yoshino, Shoji Nishida, Masaaki Iwane and Masaki Mizutani

hereby sell, assign, transfer and convey unto CANON KABUSHIKI KAISHA

a corporation of Japan

having a place of business at

3-30-2, Shimomaruko, Ohta-ku, Tokyo, Japan

its successors, assigns and legal representatives (hereinafter called the "Assignee"), the entire right, title and interest, for the United States, in and to certain inventions relating to

METHOD AND APPARATUS FOR PRODUCING SEMICONDUCTOR THIN FILMS

and described in an application for Letters Patent of the United States filed by us on September 28, 2001 and which has been accorded Application No. 09/964, 332

and in and to said application, and all divisions, and continuations thereof, and all Letters Patent of the United States which may be granted, thereon, and all reissues and extensions thereof; and we hereby authorize and request the Commissioner of Patents and Trademarks of the United States to issue all Letters Patent upon said inventions to the Assignee or to such nominees as it may designate.

AND we authorize and empower the said Assignee or nominees to invoke and claim for any application for patent or other form of protection for said inventions filed by it or them, the benefit of the right or priority provided by the International Convention for the Protection of Industrial Property, as amended, or by any convention which may henceforth be substituted for it, and to invoke and claim such right of priority without further written or oral authorization from us.

AND we hereby consent that a copy of this assignment shall be deemed a full legal and formal equivalent of any assignment, consent to file or like document which may be required in the United States for any purpose and more particularly in proof of the right of said Assignee or nominees to claim the aforesaid benefit of the right of priority provided by the International Convention for the Protection of Industrial Property, as amended, or by any convention which may henceforth be substituted for it.

AND we hereby convenant that we have the full right to convey the entire right, title and interest herein assigned and that we have not executed and will not execute any agreement in conflict herewith.

AND we hereby convenant and agree that we will communicate to said Assignee or nominees all facts known to us pertaining to said inventions, and testify in all legal proceedings, sign all lawful papers, execute all continuing and reissue applications, make all rightful oaths and declarations and in general perform all lawful acts necessary or proper to aid said Assignee or nominees in obtaining, maintaining and enforcing all lawful patent protection for said inventions in the United States.

By: Noritaka Ukiyo Noritaka Ukiyo	Date: November 22 2001
By: <u>Jetsuro Saito</u> Tetsuro Saito	Date: November 26,200/
By: Tatsumí Shojí Tatsumi Shoji	Date: Movember 26, 200/
By: Maketo - Scuatourici Makoto Iwakami	Date: - 270 wember 26. 2001
By: Jakehito Zyoshino Takehito Yoshino	Date: Morrem Blor 21, 200/

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(Page 2)

By: Moji Nishida Shoji Nishida	Date: November 22, 200/
By: Michardi Avane Masaaki Iwane	Date: Morenter 22, 200/
By: Mizutani Masaki Mizutani	Date: Marember 22, 2001
Ву:	Date:
By:	Date:
D.	Dato

RECORDED: 12/20/2001

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